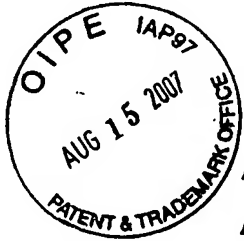


Dr**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Yair EIN-ELI et al
Application No. : 10/750,969
Filed : January 5, 2004
Title : TEXTURING A SEMICONDUCTOR MATERIAL USING
NEGATIVE POTENTIAL DISSOLUTION (NPD)

Group/Art Unit : 1742
Examiner : Nicholas A. Smith
Attorney Docket No. : 27054

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

This is in response to the United States Patent and Trademark Office Action mailed May 16, 2007, which response is being made on or before August 16, 2007, and for which no extension of time fee is due.

Applicant submits this response for entry into the record, in which:

Remarks begin on page 2